

Notice of References Cited

Application/Control No.

10/567,701

Applicant(s)/Patent Under
Reexamination
CHEN ET AL.

Examiner

JAE Y. LEE

Art Unit

2466

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,845,100	01-2005	Rinne, Mika	370/395.43
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*	E	US-2002/0181468	12-2002	Lucidarme et al.	370/395.2
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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